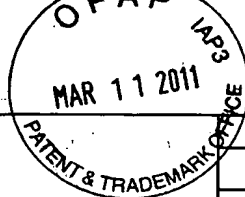


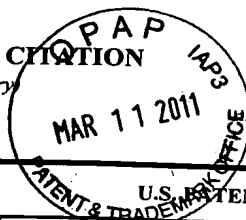
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		F06-436-US					
		APPLICANT	Mineo HIRAMATSU, Masaru HORI, and NU Eco Engineering Co., Ltd.				
		FILING DATE	GROUP				
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	TRANSLATION
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# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

F06-436-US

Application Number

10/569,838

Applicant(s)

Mineo HIRAMATSU, et al.

Filing Date

December 6, 2006

Group Art Unit

1715

## U.S. PATENT DOCUMENTS

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## U.S. PATENT APPLICATION PUBLICATIONS

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DATE CONSIDERED

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Docket Number (Optional)

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